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Docket: 0756-1638

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Application of)
Hisashi OHTANI et al.)
Based On Serial No. 08/479,211) Art Unit: 1104
Which Was Filed: June 7, 1995) Examiner: L. Radomsky
For: METHOD FOR)
MANUFACTURING)
SEMICONDUCTOR DEVICE) Date: February 27, 1997

PRELIMINARY AMENDMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Please preliminarily amend the subject application as follows:

IN THE CLAIMS:

Please cancel claims 1-18 without prejudice.

Please add new claims 19-33 as follows:

--19. A method of manufacturing a semiconductor device comprising

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